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Attorney Docket No. 0756-2424

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Osamu NAKAMURA et al.

Serial No. 10/046,893

Filed: January 17, 2002

For: METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

) Group Art Unit: 2823

) Examiner: H. Lee

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is being
) deposited with the United States Postal Service
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) envelope addressed to: Commissioner for Patents,
) P.O. Box 1450, Alexandria, VA 22313-1450, on
) 8-4-04.

Adeline M. Stamps

RESPONSE

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450


Sir:

The Official Action mailed June 9, 2004, has been received and its contents carefully noted. This response is filed within three months of the mailing date of the Official Action and therefore is believed to be timely without extension of time. Accordingly, Applicant respectfully submits that this response is being timely filed.

Paragraph 3 of the Official Action indicates that none of the certified copies of the priority documents have been received in the subject application. In response, Applicant submits herewith certified copies of JP 2001-010890 filed January 18, 2001; JP 2001-019357 filed January 29, 2001; and JP 2001-022398 filed January 30, 2001. Upon filing of the priority documents, the present invention is now believed to be in condition for allowance and a formal *Notice of Allowance* is requested.

Should the Examiner believe that anything further would be desirable to place this application in better condition for allowance, the Examiner is invited to contact the undersigned at the telephone number listed below.

Respectfully submitted,



Eric J. Robinson
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